

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Number: 7,259,850

Serial No.: 10/757,204

Issued: August 21, 2007

Inventor(s): Chih-Ming Ke et al.

Title: APPROACH TO IMPROVE ELLIPSOMETER MODELING ACCURACY
FOR SOLVING MATERIAL OPTICAL CONSTANTS N & K

Attention Certificate of Corrections Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**REQUEST FOR CERTIFICATE OF CORRECTION OF
PATENT FOR PTO MISTAKE (37 CFR 1.322)**

Dear Sir:

1. Attached is Form PTO/SB/44 wherein the errors occurring in the printed patent are noted by column and line number.
2. The exact page and line number where the correct language appears in the application file is:

Amendment After Allowance, 37 CFR §1.312 filed 6/26/2007, Page 2, Claim 2,
Lines 1 and 2;

Amendment After Allowance, 37 CFR §1.312 filed 6/26/2007, Page 3, Claim 6
(now Claim 4), Line 1;

Amendment After Allowance, 37 CFR §1.312 filed 6/26/2007, Page 5, Claim 23
(now Claim 17), Line 2; and

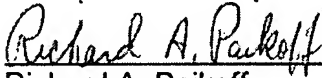
Amendment After Allowance, 37 CFR §1.312 filed 6/26/2007, Page 5, Claim 23
(now Claim 17), Line 5.

3. Please send the Certificate to:

Name: Steven E. Koffs, Esquire
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Respectfully submitted,

Date: 11/12/07


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CERTIFICATE OF CORRECTION

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APPLICATION NO.: 10/757,204
ISSUE DATE : August 21, 2007
INVENTOR(S) : Chih-Ming Ke, Pei-Hung Chen, Shinn-Sheng Yu

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 10, lines 53-56, delete "The method of claim 1 wherein the integrated optical measurement systems is an Opti-Probe series measurement system from Therna-Wave or a system with equivalent capability" and insert therefore - - The method of claim 1 wherein said organic or inorganic layer has a thickness in the range of about 300 to 10000 Angstroms. - -


Column 10, line 57, delete "in the".

Column 12, line 15, delete "trillayer" and insert therefore - - trilayer - - .

Column 12, line 20, delete photorsist" and insert therefore - - photoresist - - .

MAILING ADDRESS OF SENDER (Please do not use customer number below):

Richard A. Paikoff, Duane Morris LLP
30 South 17th Street
Philadelphia, PA 19103

 This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.